

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10010950	FILING DATE 11/13/2001	CLASS 438	SUBCLASS 637	GAU 2812	EXAMINER D. LE
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5C5/503

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\*\*CONTINUING DATA VERIFIED:  
THIS APPLN CLAIMS BENEFIT OF 60/328,018 10/09/2001

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\*\* FOREIGN APPLICATIONS VERIFIED:

PO/PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 6392/DD/LOW K/JW
TITLE : Method of depositing low k barrier layers		
U.S. DEPT. OF COMM/PAT & TM-PTO-436L (Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims Print Claim for 0.6
ISSUE FEE		Primary Examiner	DRAWING
Amount Due	Date Paid		Sheets Drawn. <input type="checkbox"/> Fig. Drawn. <input type="checkbox"/> Print Fig. <input type="checkbox"/>
TERMINAL		Application Examiner	
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